



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

September 7, 2026

IGI Report Number

LG835664954

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

EMERALD CUT

Measurements

8.42 X 6.08 X 4.21 MM

GRADING RESULTS

Carat Weight

2.10 CARATS

Color Grade

E

Clarity Grade

VVS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG835664954

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

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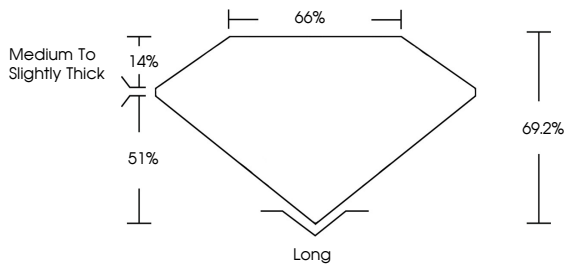
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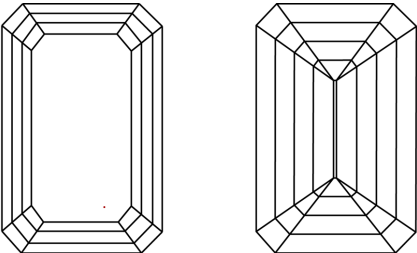
PROPORTIONS





Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D	E	F	G	H	I	J	Faint	Very Light	Light
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CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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EMERALD CUT

8.42 X 6.08 X 4.21 MM

Carat Weight

2.10 CARATS

Color Grade

E

Clarity Grade

VVS 2

Depth

51%

Table

14%

Girdle

Medium to Slightly Thick

Culet

Long

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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